



ITW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
)  
Nobuo ISHII et al. ) Group Art Unit: 1763  
)  
Serial No.: 10/519,775 ) Examiner: Rakesh Kumar Dhingra  
)  
Filed: December 29, 2004 )  
) Confirmation No.: 7307  
For: PLASMA PROCESSING )  
APPARATUS AND )  
CONTROLLING METHOD )  
THEREFOR )  
)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REPLY TO OFFICE ACTION**

In reply to the Office Action mailed June 11, 2007, please amend the  
above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks/Arguments** follow the amendment sections of this paper.